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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

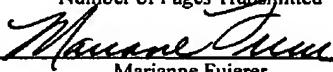
In re United States Patent Application of:)	Docket No.:	ATMI-546 CIP1 (7494)
)		Examiner	J.M. St. Surin
Applicant:)	Group Art Unit:	2856
Serial No.:)	Confirm. No.	8335
Date Filed:)	Customer No.:	
Title:)	25559	
NICKEL-COATED FREE-STANDING SILICON CARBIDE STRUCTURE FOR SENSING FLUORO OR HALOGEN SPECIES IN SEMICONDUCTOR PROCESSING SYSTEMS, AND PROCESSES OF MAKING AND USING SAME			

FACSIMILE TRANSMISSION CERTIFICATE

I hereby certify that I am filing this document in the U.S. Patent and Trademark Office on September 16, 2005, by facsimile transmission, and addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 and transmitted to USPTO Central Facsimile No. (571) 273-8300.

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Number of Pages Transmitted



Marianne Fuierer

September 16, 2005

Date

**RESPONSE TO JUNE 16, 2005 OFFICE ACTION
IN U. S. PATENT APPLICATION NO. 10/784,606**

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the June 16, 2005 Office Action in the above-identified application, please amend the application as follows: